

ABSTRACT OF THE DISCLOSURE

Device for holding an object under a vacuum and processes for making this device, application to uncooled infrared detectors.

According to the invention, a leak tight cavity (16) that contains the object (2) and in which the vacuum is created, and a getter (22) designed to trap gases that could be located in the cavity are formed. The getter is placed outside the cavity and is contained in a leak tight housing (18) connected to this cavity through at least one leak tight passage (26).

Single figure.